

10/529362

Docket No.: 970 1011
JC17 Rec'd PCT/PTO 28 MAR 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of 35 U.S.C. §371:

Toshiaki KAKEMURA et al.

Based Upon International Application No.
PCT/JP03/12334

Group Art Unit: Unassigned

International Filing Date: September 26, 2003

Examiner: Unassigned

US Filing Date:

For: THIN FILM FORMING METHOD, THIN FILM FORMING DEVICE, AND THIN FILM
FORMING PROCESS MONITORING METHOD

PRELIMINARY AMENDMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

Before examination of the above-identified application, please amend the application as follows: